

Attorney Docket No. 033082 M 275

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:		) CON	CONFIRMATION NO.: 6774		
K	Cazuhide HASEBE, et al.	) )			
U.S. Seri	ial No.: 10/552,262	) Grou	p Art L	Init: 1765	
Filed: C	October 5, 2005	) Exam	niner:	Lan Vinh	
For: S	SILICON DIOXIDE FILM REMOV	ING METHO	DD AN	D PROCESSING SYSTEM	

## **RESPONSE TO OFFICE ACTION DATED SEPTEMBER 26, 2007**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is in reply to the Office Action mailed September 26, 2007, to which the time for response was set to expire December 26, 2007. A Petition for Extension of Time for one month and the requisite fee are submitted herewith to extend the date for reply up to and including January 26, 2008. Therefore, please accept this Response as timely filed.

Kindly amend the above-identified patent application as set forth in the listing of claims below.